

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Hongyong Zhang	Art Unit	: 2814
Serial No.	: 09/362,808	Examiner	: Shrinivas H. Rao
Filed	: July 28, 1999	Conf. No.	: 7320
Title	: METHOD OF FABRICATING SEMICONDUCTOR DEVICE		

Commissioner for Patents
P.O. Box 1450
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AMENDMENT ACCOMPANYING RCE

Please amend the application as indicated on the following pages:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.